



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Nathan R. Brown

Serial No.: 10/715,264

Filed: November 17, 2003

For: METHODS FOR DETERMINING
AMOUNTS AND LOCATIONS OF
DIFFERENTIAL PRESSURE TO BE APPLIED
TO SEMICONDUCTOR SUBSTRATES DURING
POLISHING OF SEMICONDUCTOR DEVICE
STRUCTURES CARRIED THEREBY AND FOR
SUBSEQUENTLY POLISHING SIMILAR
SEMICONDUCTOR DEVICE STRUCTURES

Confirmation No.: 5086

Examiner: S. Macarthur

Group Art Unit: 1763

Attorney Docket No.: 2269-4375.3US
(99-1029.03US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

January 19, 2006
Date

Signature

Erika Gandre

Name (Type/Print)

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner:

This Amendment follows the Office Action of October 19, 2005, the three-month shortened statutory period for response to which expires on January 19 2006.

Amendments to the specification appear on page 2 of this paper; and

Remarks start at page 3 of this paper.